



Docket No.: 87289.1741
Customer No. 30734

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

ELWOOD *et al.*

Serial No. 10/022,194

: Group Art Unit: 2121

Filed: December 20, 2001

: Examiner:

For: EQUIPMENT MONITORING SYSTEM AND METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks
Washington, D. C. 20231

Sir:

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In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449.

It is respectfully requested that the documents be expressly considered and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

No further elaboration is believed necessary. Copies of the prior art are submitted herewith in accordance with 37 C.F.R. §1.98(a).

Docket No. 87289.1741



PATENT

AUTHORIZATION

This Information Disclosure Statement is being filed before receipt of the first Office Action. No fee is required. The Commissioner is hereby authorized to charge any additional fees which may be required for this submission, or credit any overpayment to deposit account no. 50-2036.

Respectfully submitted,

BAKER & HOSTETLER LLP

A handwritten signature in black ink, appearing to read "Dennis P. Cawley".

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LIST OF ART CITED BY APPLICANT

(PTO-1449)

ATTY. DOCKET NO.
87289.1741

SERIAL NO.
10/022,194

APPLICANT
ELWOOD et al.

FILING DATE
12/20/01

GROUP
2121

U. S. PATENT DOCUMENTS

| EXAMINER'S INITIALS | PATENT NO. | DATE | NAME | CLASS | SUBCLASS | FILING DATE |
|---------------------|------------|----------|---------------|-------|----------|-------------|
| A | 6,262,550 | 07/17/01 | Kliman et al. | 318 | 565 | 12/17/99 |
| B | 4,125,892 | 11/14/78 | Fakuda et al. | 364 | 200 | 06/29/77 |
| C | 4,032,907 | 06/28/77 | Young | 340 | 213R | 08/08/75 |
| D | | | | | | |
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FOREIGN PATENT DOCUMENTS

| EXAMINER'S INITIALS | PATENT NO. | DATE | COUNTRY | CLASS | SUBCLASS | Translation |
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| U | | | | | | |
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.